



IPW

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q79657

Kazutoshi SHIBA, et al.

Appln. No.: 10/767,335

Group Art Unit: 2814

Confirmation No.: 5230

Examiner: Shrinivas H. RAO

Filed: January 30, 2004

For: SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE SAME

AMENDMENT UNDER 37 C.F.R. § 1.111

MAIL STOP AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated March 10, 2005, please amend the above-identified application as follows on the accompanying pages.

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